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**ATTY DOCKET: NMTI 1002-4**

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WVW  
Amy Jonsson

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re Application of:**

Christophe Pierrat et al.

Application No.: 09/972,428

Filed: 5 October 2001

**Title: EXPOSURE CONTROL FOR PHASE SHIFTING PHOTOLITHOGRAPHIC MASKS**

Group Art Unit: 2812

Examiner: Not yet assigned

**REQUEST FOR CORRECTED FILING RECEIPT**

Commissioner of Patents  
Washington, D.C. 20231

Sir:

Enclosed is a copy of the official Filing Receipt marked in red to identify the correction needed. The correction is as follows:

Please change the firm name in the mailing address from "Numerical c/o Haynes Beffel & Wofield LLP" to -- Numerical c/o Haynes Beffel & Wolfeld LLP --.

Please change the name of the first inventor from “Christopher Pierrat” to -- **Christophe Pierrat** --.

Please change the name of the second inventor from “Michael Luc Cote” to -- Michel  
**Luc Cote --.**

Since the error was not caused by applicant, but by the Patent Office, no fee is believed necessary. However, the Commissioner is hereby authorized to charge any additional fees which may be required by this paper, or to credit any overpayment to Deposit Account No. 50-0869 (NMTI 1002-4). This paper is submitted in duplicate.

Respectfully submitted,

Date: 18 December 2001

Mark A. Haynes  
Registration No. 30,846

NUMERICAL C/O:  
HAYNES BEFFEL & WOLFELD LLP  
P.O. Box 366  
Half Moon Bay, CA 94019  
Phone: (650) 712-0340



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## UNITED STATES PATENT AND TRADEMARK OFFICE

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/972,428	10/05/2001	2812	1538	NMTI 1002-4	6	55	5

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NUMERICAL C/O HAYNES BEFFEL & WOLFELD LLP  
 PO BOX 366  
 751 KELLY STREET  
 HALF MOON BAY, CA 94019

WOLFELD

CONFIRMATION NO. 3974

## FILING RECEIPT



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Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Christophe → Christopher Pierrat, Santa Clara, CA;  
 Michel → Michael Luc Cote, San Jose, CA;

## Domestic Priority data as claimed by applicant

THIS APPLN CLAIMS BENEFIT OF 60/296,788 06/08/2001  
 AND CLAIMS BENEFIT OF 60/304,142 07/10/2001

HAYNES BEFFEL &amp; WOLFELD LLP

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## Foreign Applications

If Required, Foreign Filing License Granted 11/08/2001

Projected Publication Date: 12/12/2002

Non-Publication Request: No

Early Publication Request: No

## Title

Exposure control for phase shifting photolithographic masks

## Preliminary Class

438

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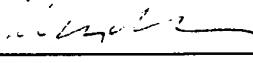
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